

## **Tineke Thio**

Arinna LLC  
79 Dempsey Avenue  
Princeton, NJ 08540

Email [tineke@arinnaresearch.com](mailto:tineke@arinnaresearch.com)  
Phone +1 (609) 610 2018  
<http://www.arinnaresearch.com>

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*Professional* Research in nanophotonics and applications.

*Interest*

*Publications*

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37. S.A. Solin, **Tineke Thio**, J.W. Bennett, D.R. Hines, M. Kawano, N.



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74. Tineke Thio, H.J. Lezec, T.W.

*Patents*

- #73,3-06 B16 **US Patent** # 5,696,655 (9Dec1997); priority US 688583 (960730);  
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2. **US Patent** # 5,804,842 (1998); priority US 493181;  
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“Optically writing erasable conductive patterns at a bandgap-engineered heterojunction”,  
T. Thio.
3. **US Patent** # 5,920,409 (6Jul1999); priority US 22564P (0408);  
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4. **US Patent** # 5,965,283 (12oct1999); priority US 997264;  
Japanese Publ. # JP 11-250422 A (17Sep1999);  
“GMR enhancement in semihotoconorsment JP10”



*MENTORING AND SUPERVISING*

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